
The First Result of the 28GHz Superconducting ECR Ion Source at KBSI



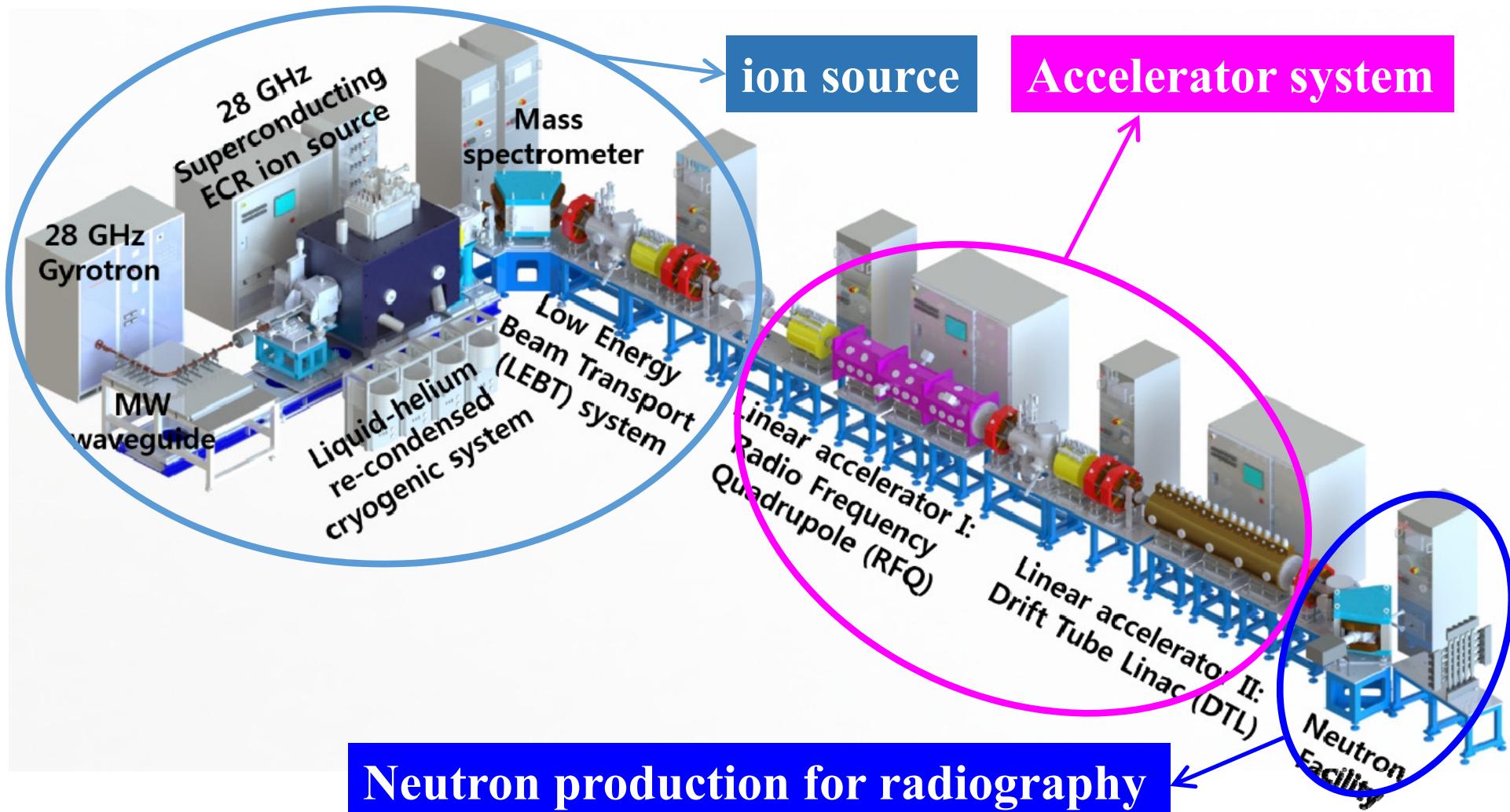
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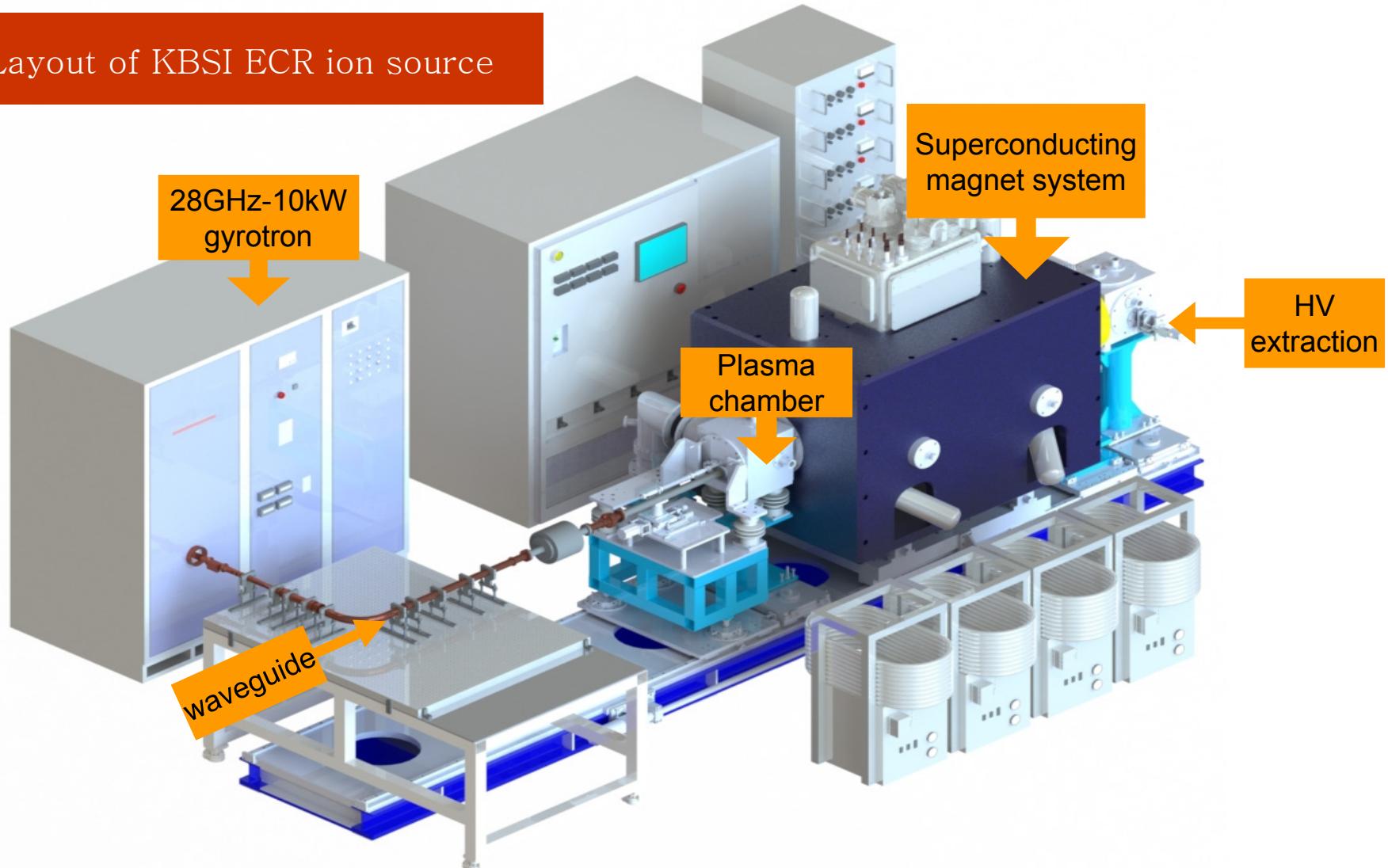
- » **KBSI 28GHz ECR Ion Source**
- » **X-ray and Ion beam Measurement system**
- » **First Results of ion Beam Charge Spectra & X-ray measurement**
- » **Conclusion & Future Plan**

KBSI Accelerator System for Neutron Facility

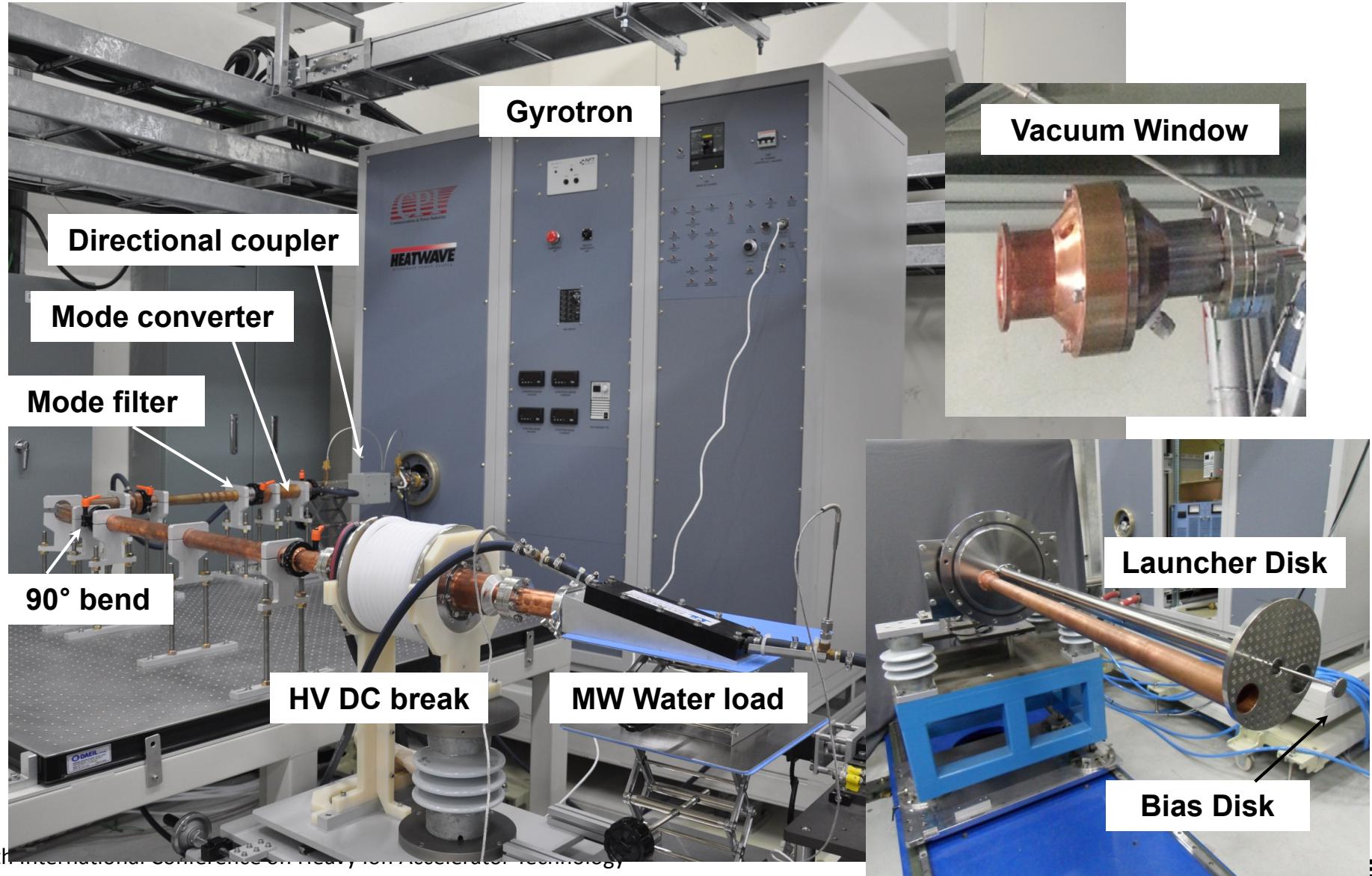


Configuration of KBSI 28 GHz ECR Ion Source

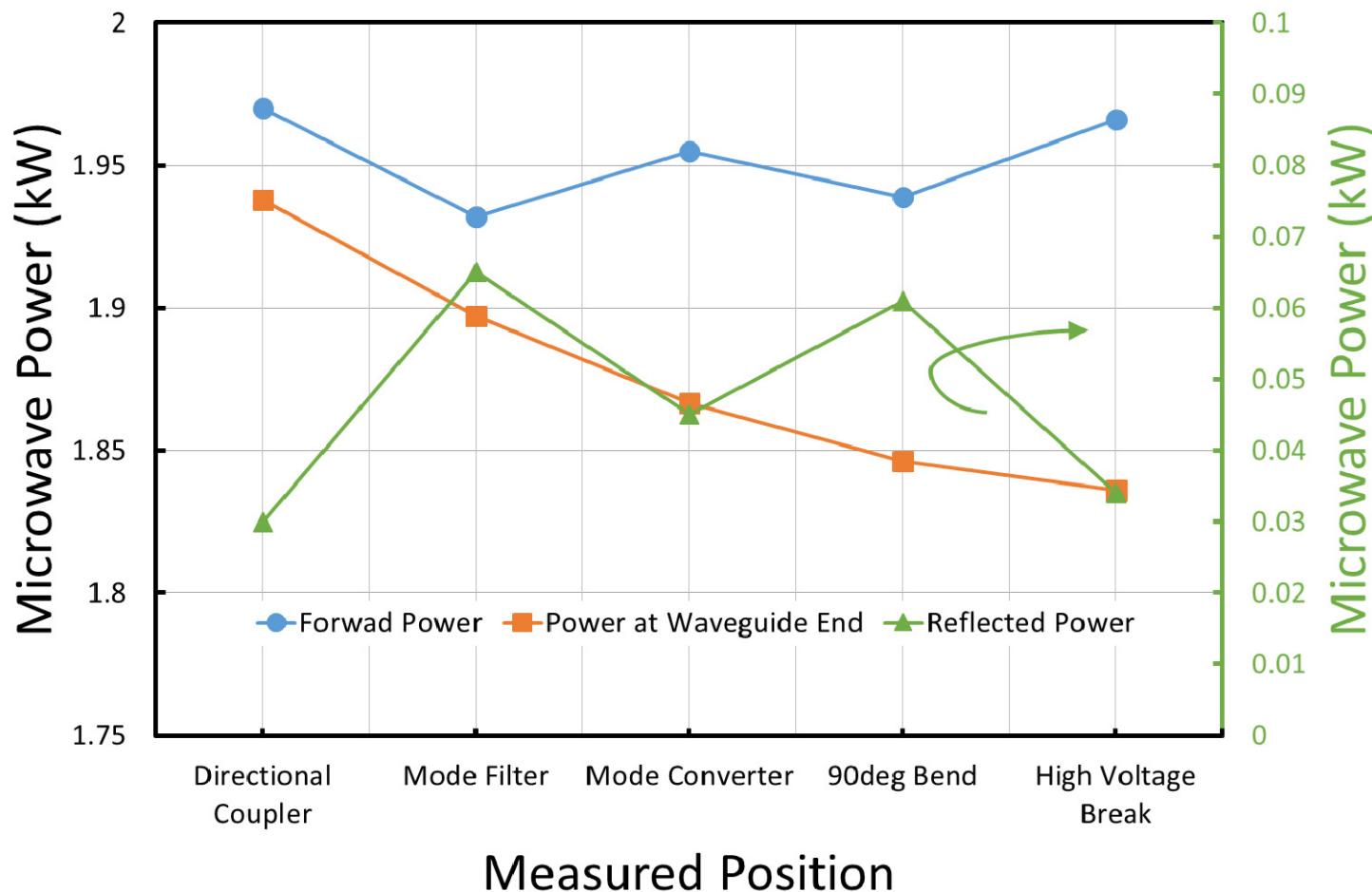
Layout of KBSI ECR ion source



28GHz Microwave System

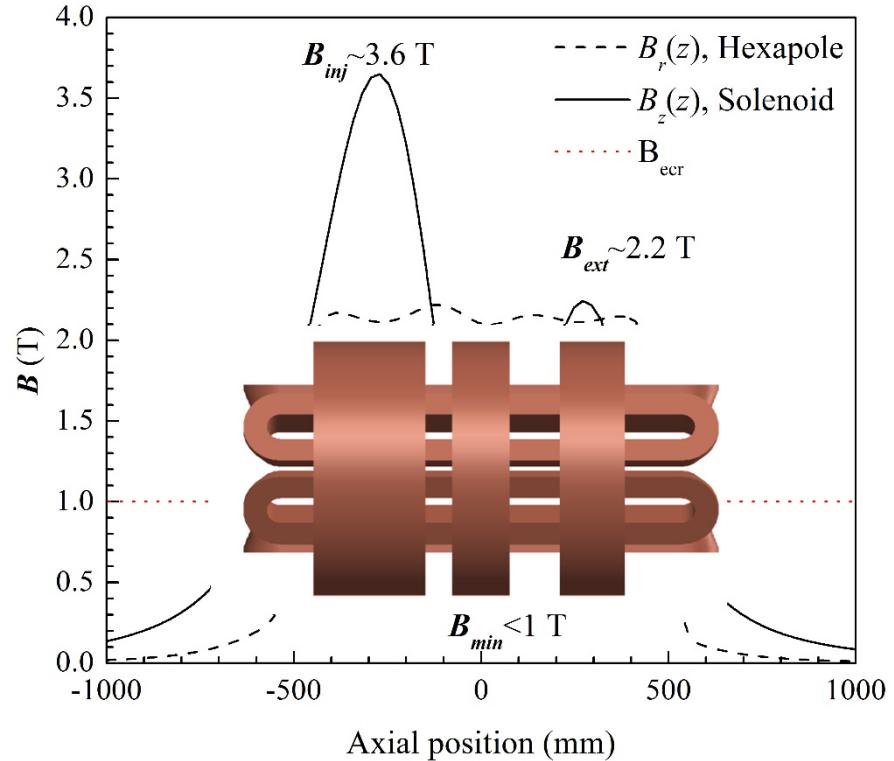
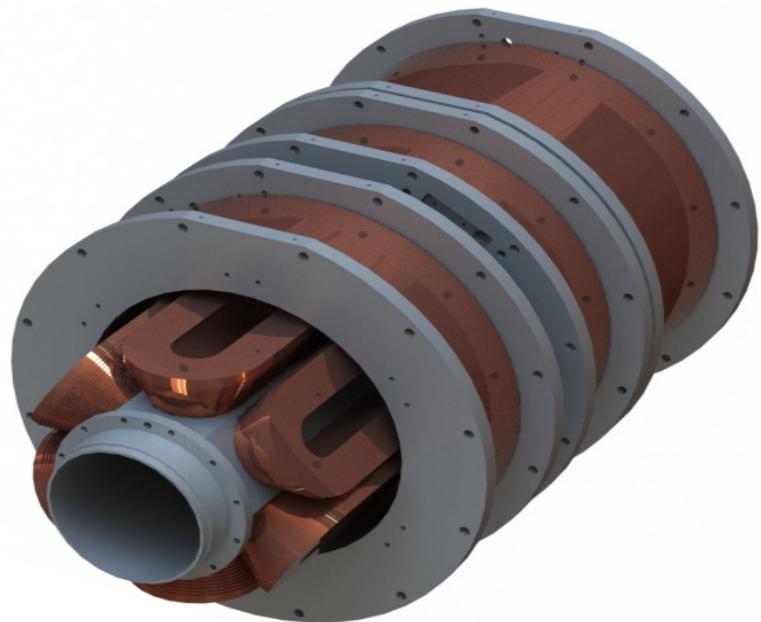


Microwave Power Transmission System



- The transmitted power to plasma chamber is above 92% at 2 kW

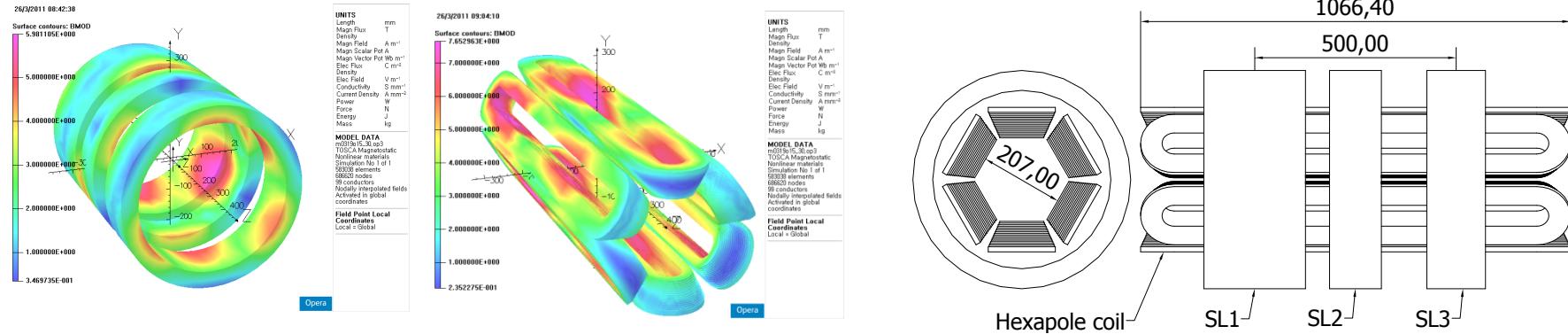
Superconducting magnet system: Design results



3 Solenoid + 1 hexapole magnet (6 step-type coils)

- The axial field: ~3.6 T at injection, ~2.2 T at extraction.
- The minimum axial field (variable): 0.4 ~ 0.8 T.
- The radial design field on the plasma chamber wall: 2.1 T

Superconducting magnet system: Design results



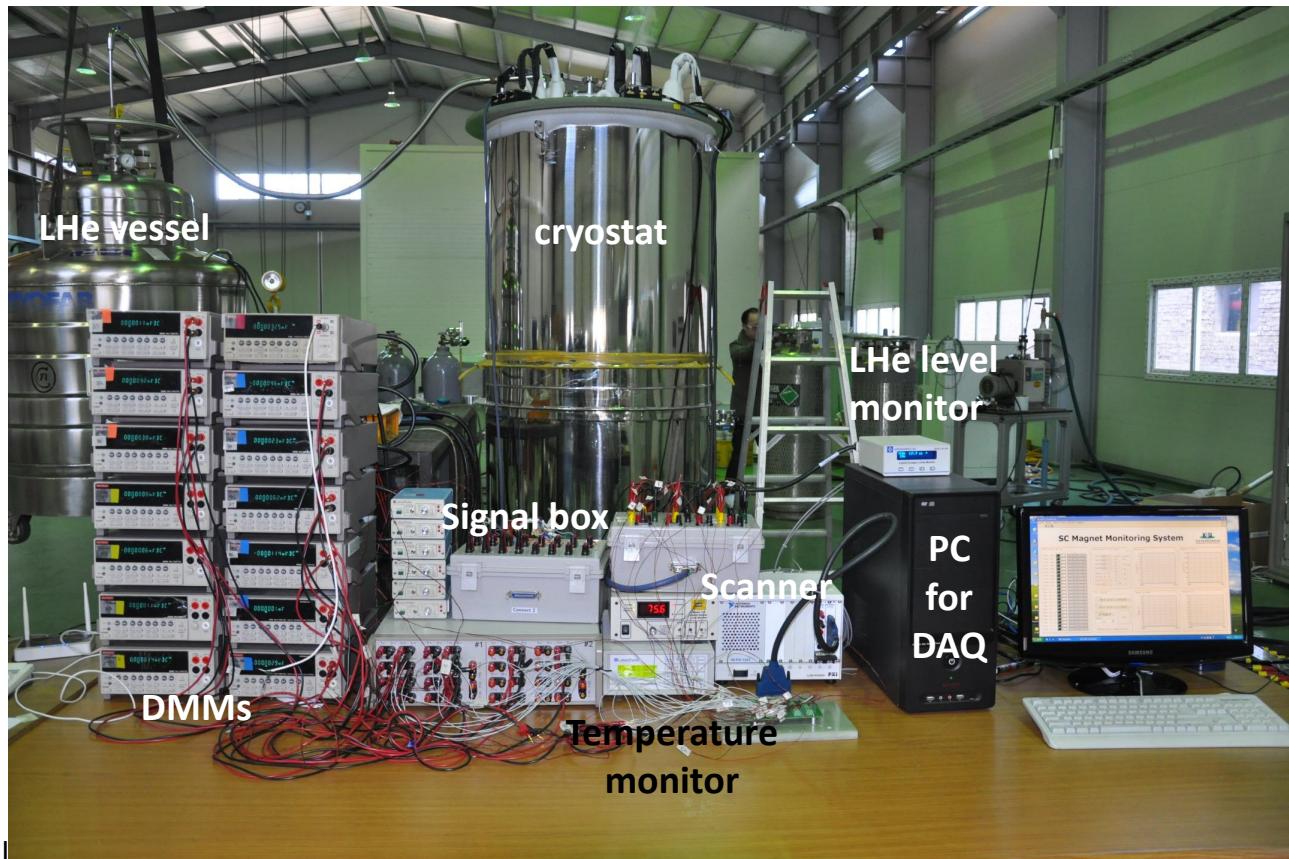
	SL1	SL2	SL3	Hexapole
Axial position of center (mm)	-250	+250	0	0
Inner diameter (mm)	442	442	442	207
Outer diameter (mm)	540.8	540.8	540.8	394.96
Depth (mm)	49.4	49.4	49.4	75.6
Width (mm)	252	128.8	145.6	53.2
Hexapole length (mm)	-	-	-	1066.4
Hexapole inner radius (mm)	-	-	-	30
Conductor size (mm)	0.95 x 1.4	0.95 x 1.4	0.95 x 1.4	0.95 x 1.4
Cu/NbTi ratio	4.9	4.9	4.9	2.32
Turns/coil	9360	4784	5408	2304
Wire lengths/coil (km)	14.5	7.4	8.4	4.9
Current (A)	197	198	197	263
B _{max} (T)	5.98	5.35	4.72	7.65
Inductance (H)	39	13.5	16.5	23

Initial performance test of superconducting magnet

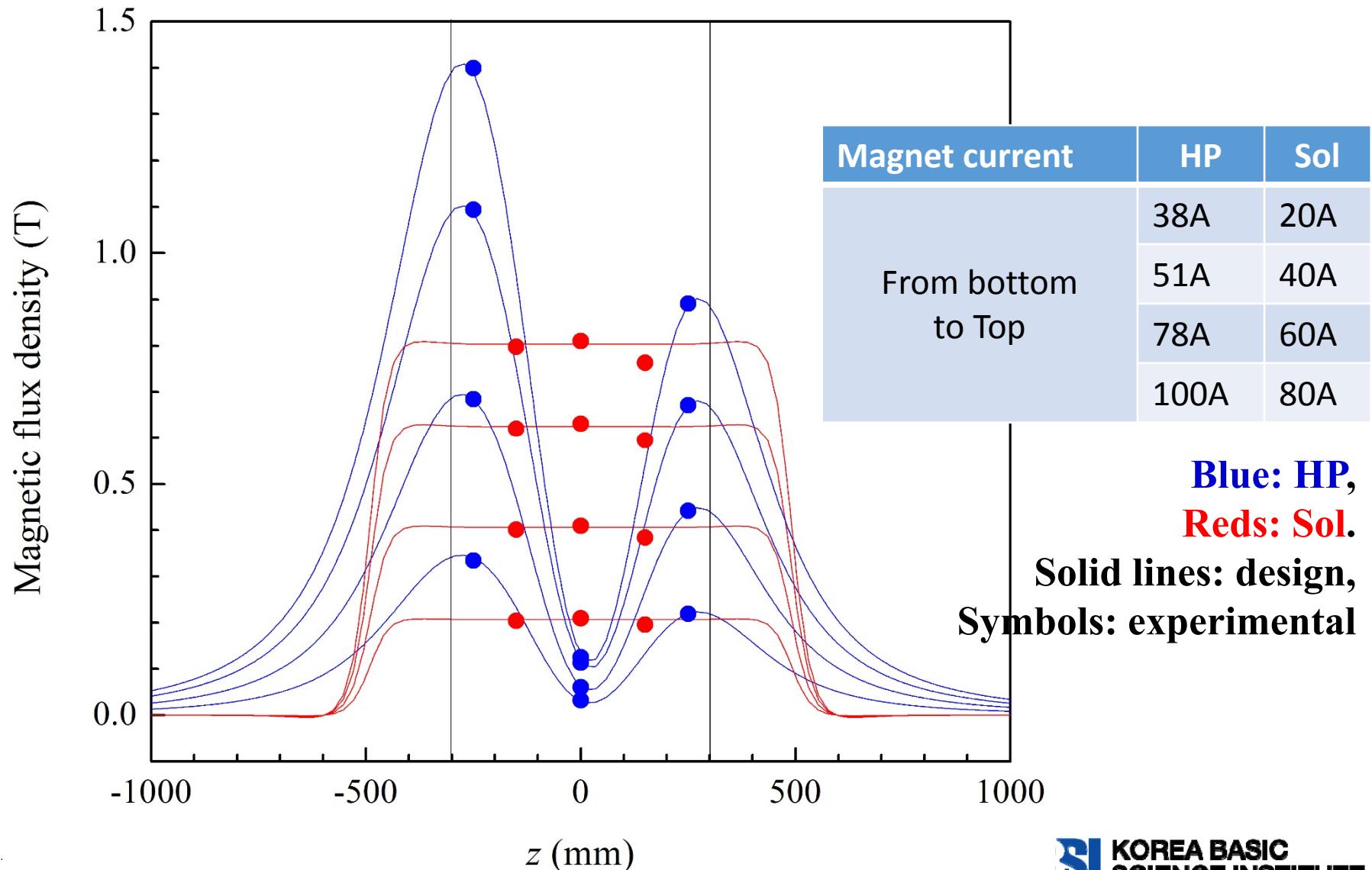


Magnet test at open-type cryostat

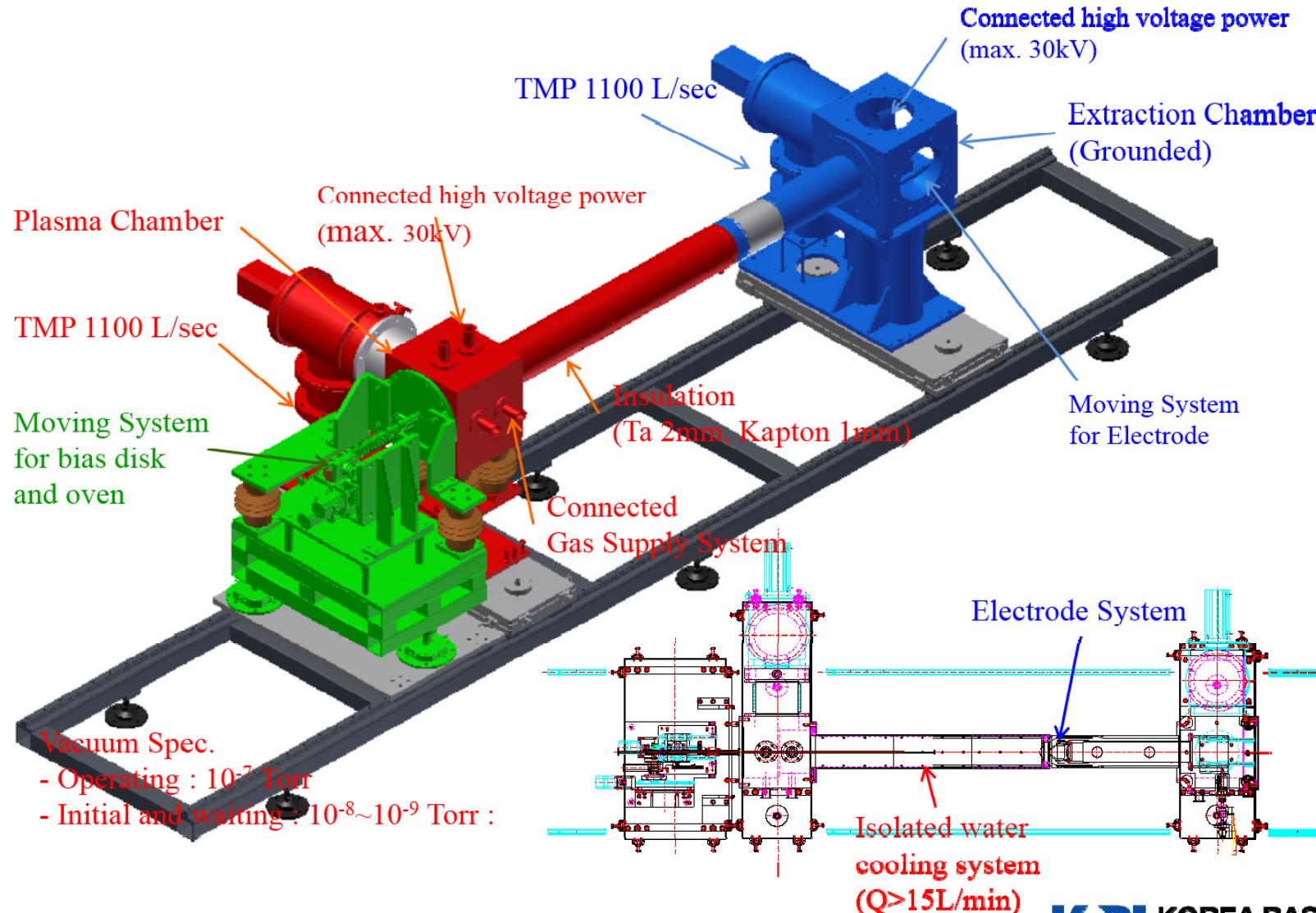
- Separate coil performance was checked before final assembly
- Vertical cryostat(open type) was prepared for convenient test
- Magnet status, temperature, magnetic field were observed



The comparison of magnet field between design and experimental values



Plasma Chamber & Extraction System

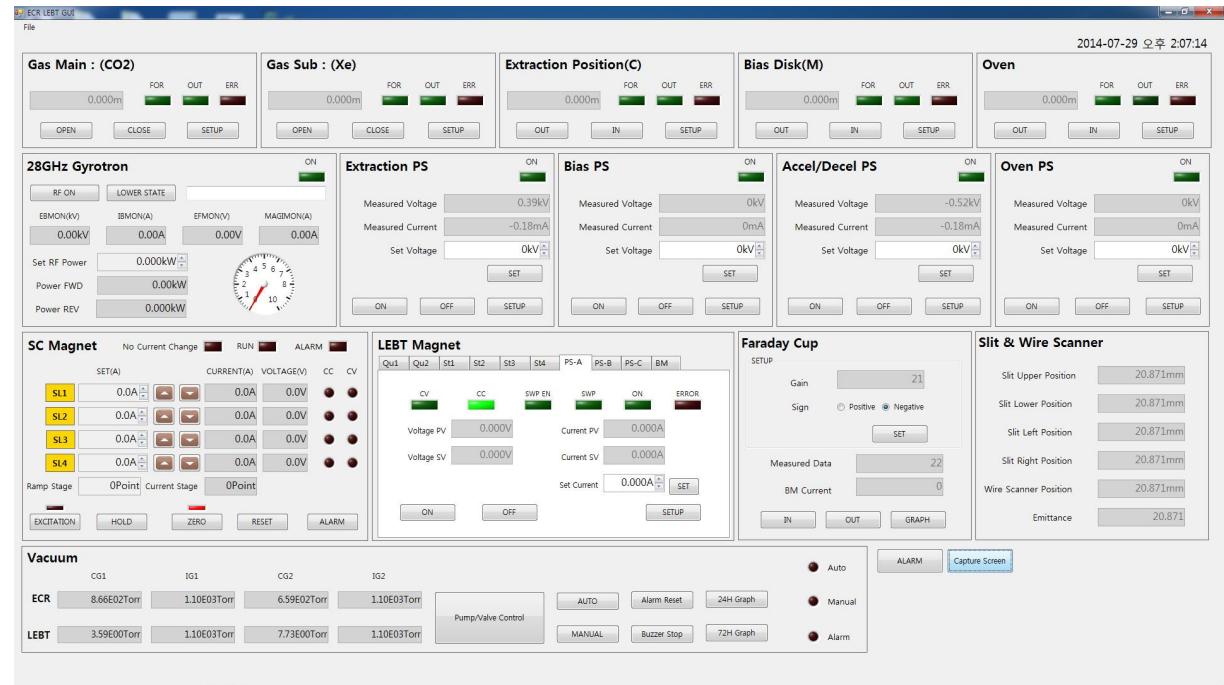


Remote control Program

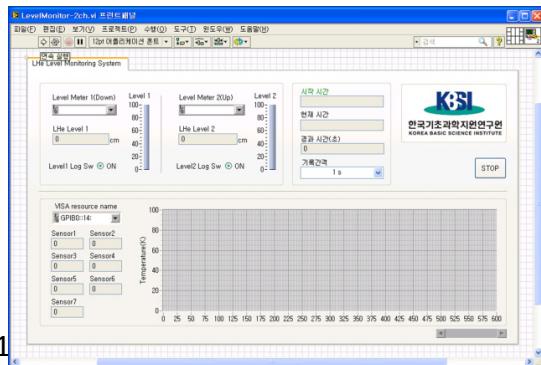
■ Control Cabinet



■ Main Control Program



■ SC magnet monitoring



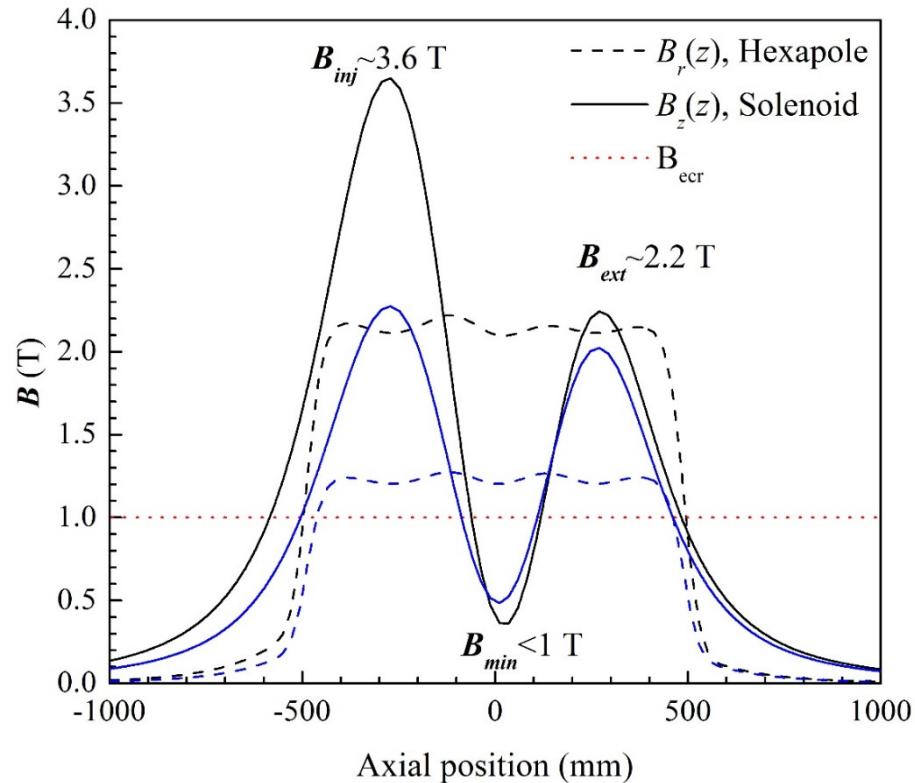
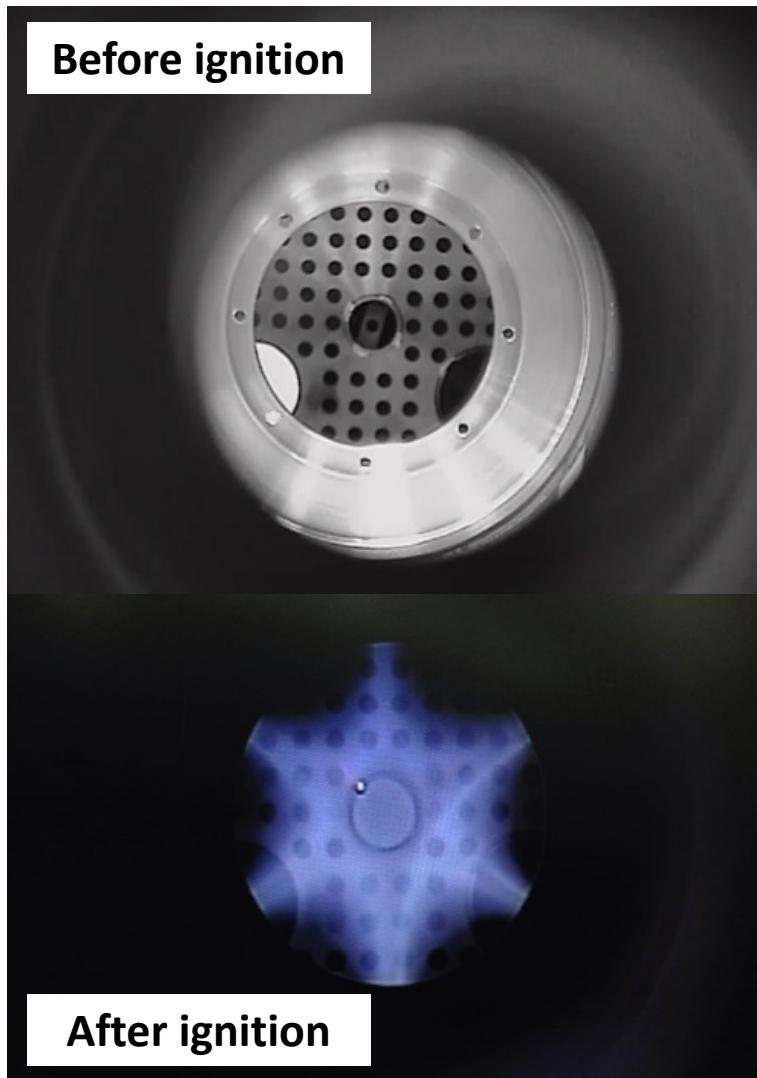
in Accelerator

■ Beam Diagnostic Program



1

First plasmas ignition

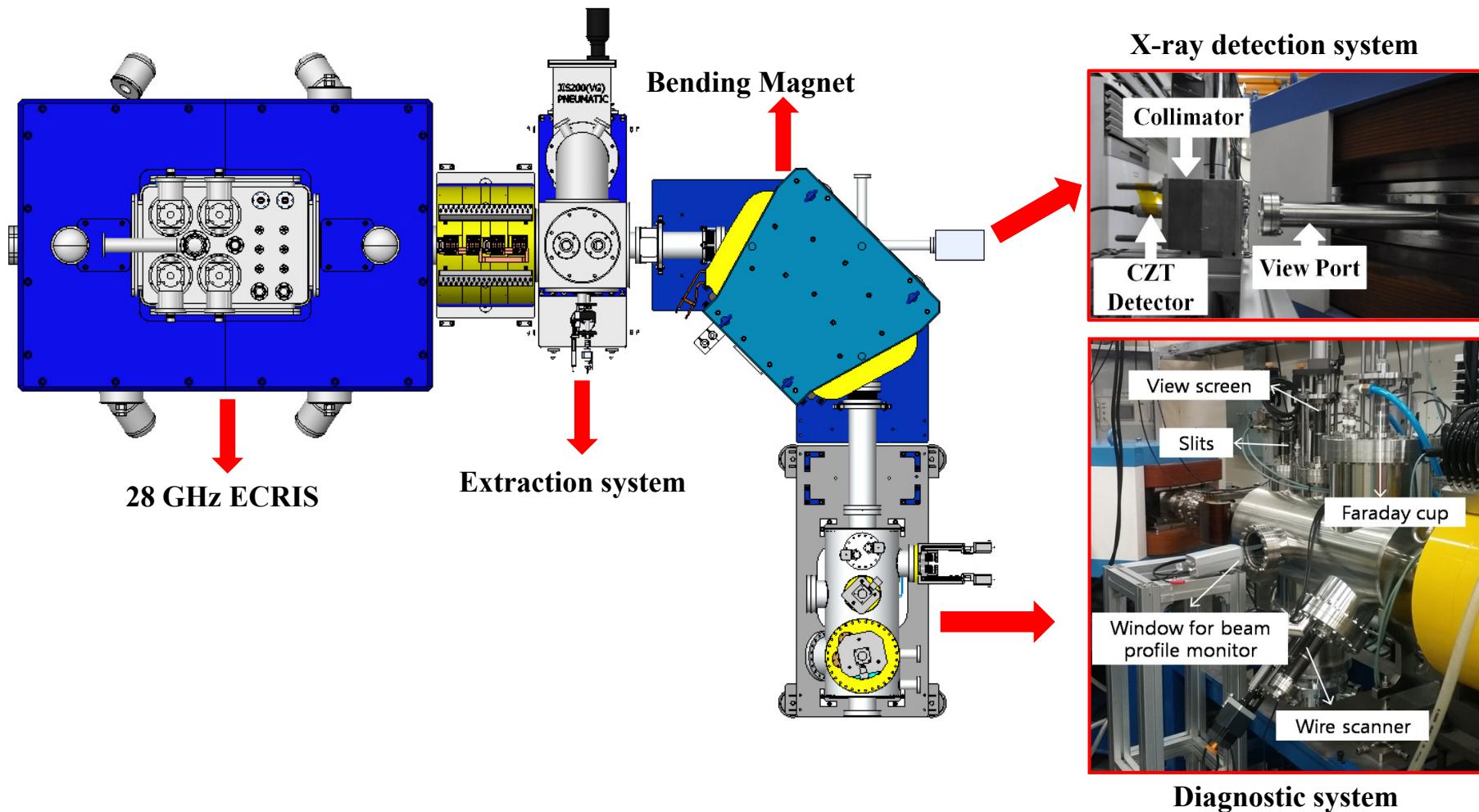


Black lines: Design values,

Blue lines: Plasma ignition condition

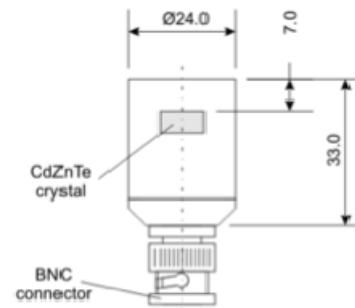
- ※ Training of superconducting magnet has been much delayed due to LHe shock.
- ※ Solenoids performance is now limited by yet-trained Hexapole-magnet.

X-ray and Ion beam measurement system



Calibration of the CZT detector

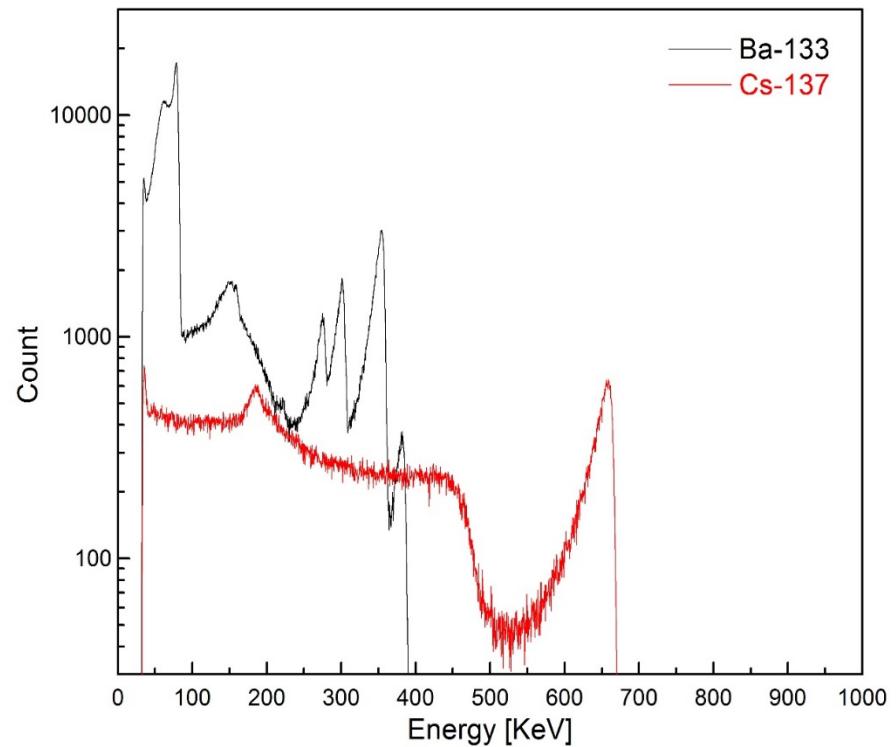
❖ Specification of the CZT detector



Specification

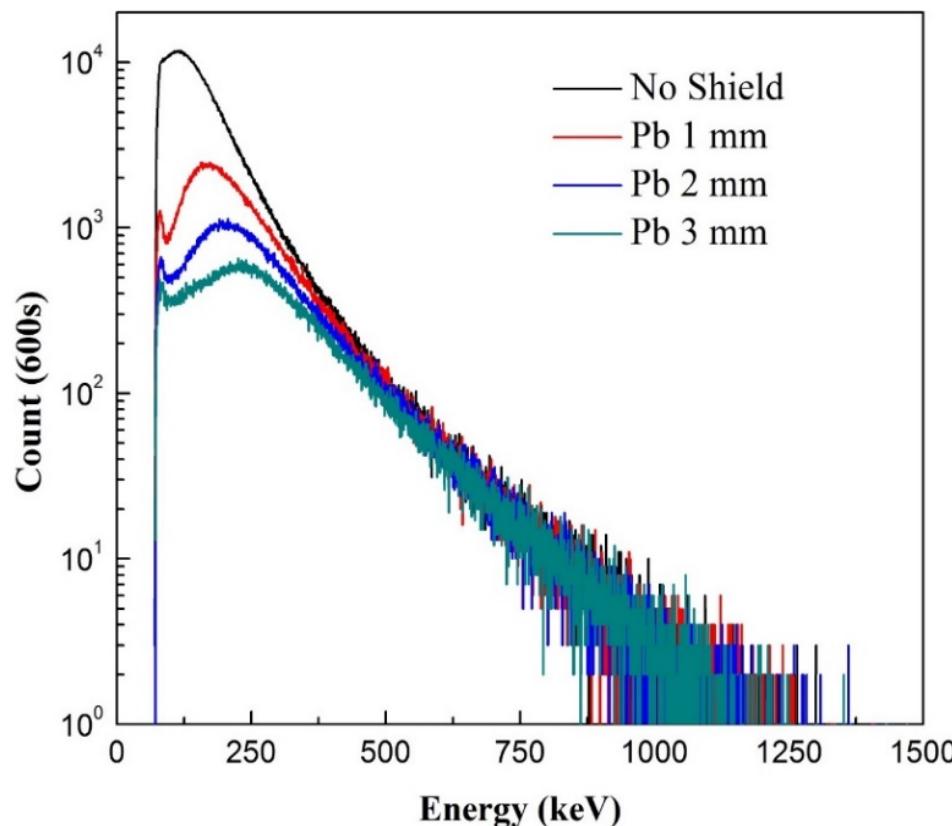
Detector name	CZT/500S
Vendor	Ritec Ltd.
Year of fabrication	1998
<i>Basic</i>	
Detector type	CdZnTe
Detector geometry	Quasi-hemispherical
Detector sensitive volume	500 mm ³
<i>Bias voltage requirements</i>	
Detector high voltage	1000 V
Detector high-voltage polarity	Positive
<i>Dimensions</i>	
Diameter	23 mm
Length	33 mm
Distance between a top plane of the housing cover and sensitive surface of the detector	7 mm
<i>Connector</i>	
Detector bias voltage	BNC or SHV type

❖ Calibrated energy distribution



Measured x-ray spectra with respect to the thickness of Pb sheets

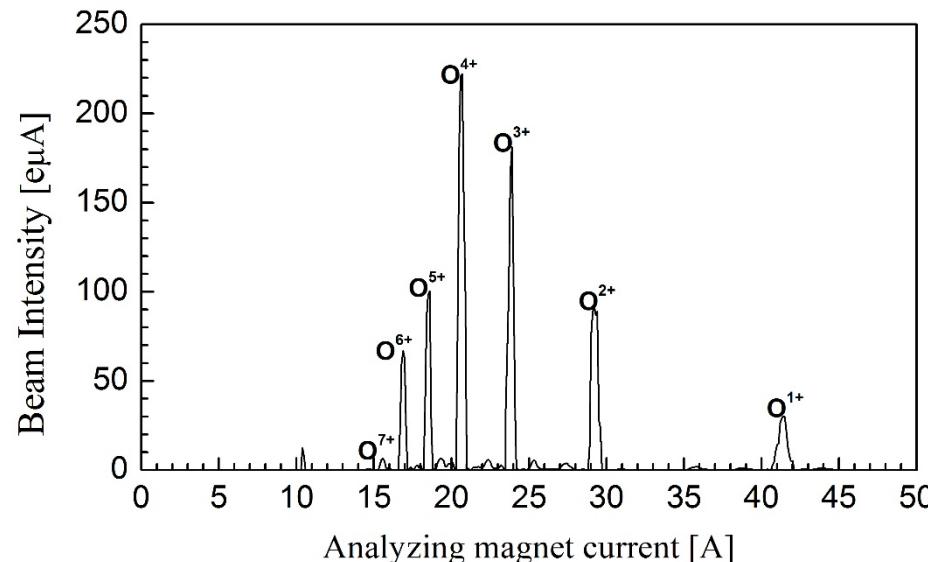
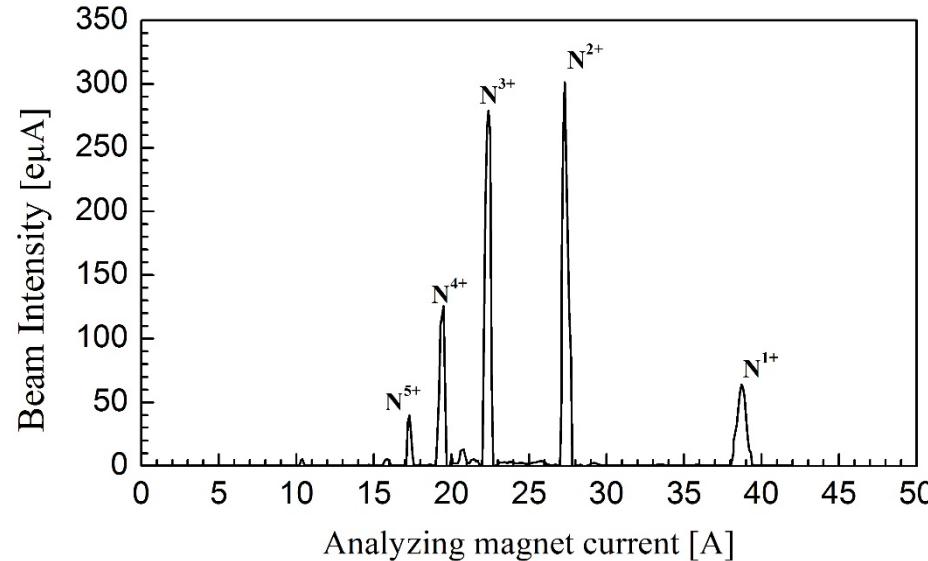
- ◆ a comparison of x-ray energy distribution as a function of the thickness of the lead shielding



Pb Sheet	Shielding rate(<600 keV)
1 mm	60 %
2 mm	75 %
3 mm	82 %

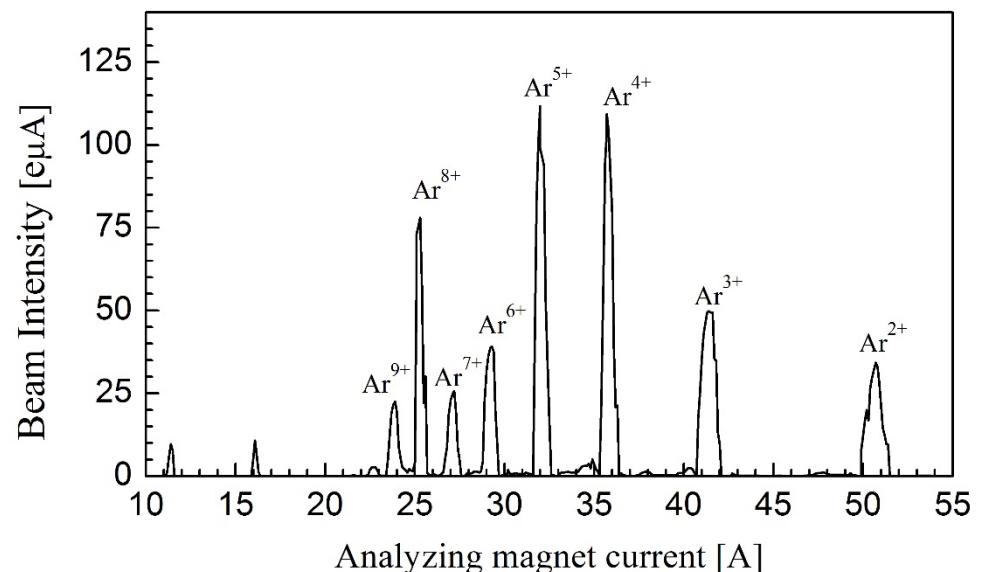
- ◆ The x-ray shielding rate was found to be 80 % for 3 mm thick lead shielding

Ion Beam charge spectra

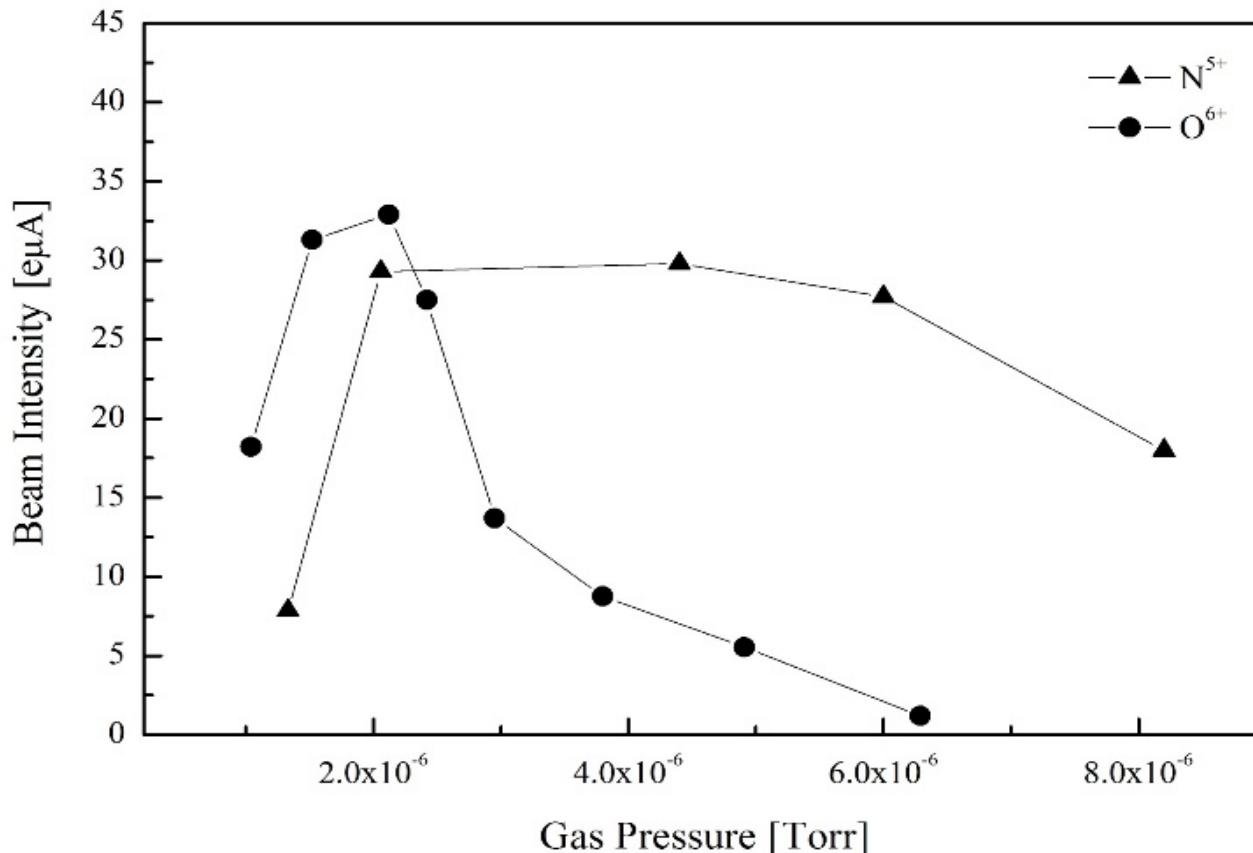


Operation conditions

- Microwave Power = 1 kW
- $B_{\text{inj}} = 2.3 \text{ T}$, $B_r = 1.2 \text{ T}$, $B_{\text{ext}} = 2 \text{ T}$
- 13 kV (extraction voltage was fixed)

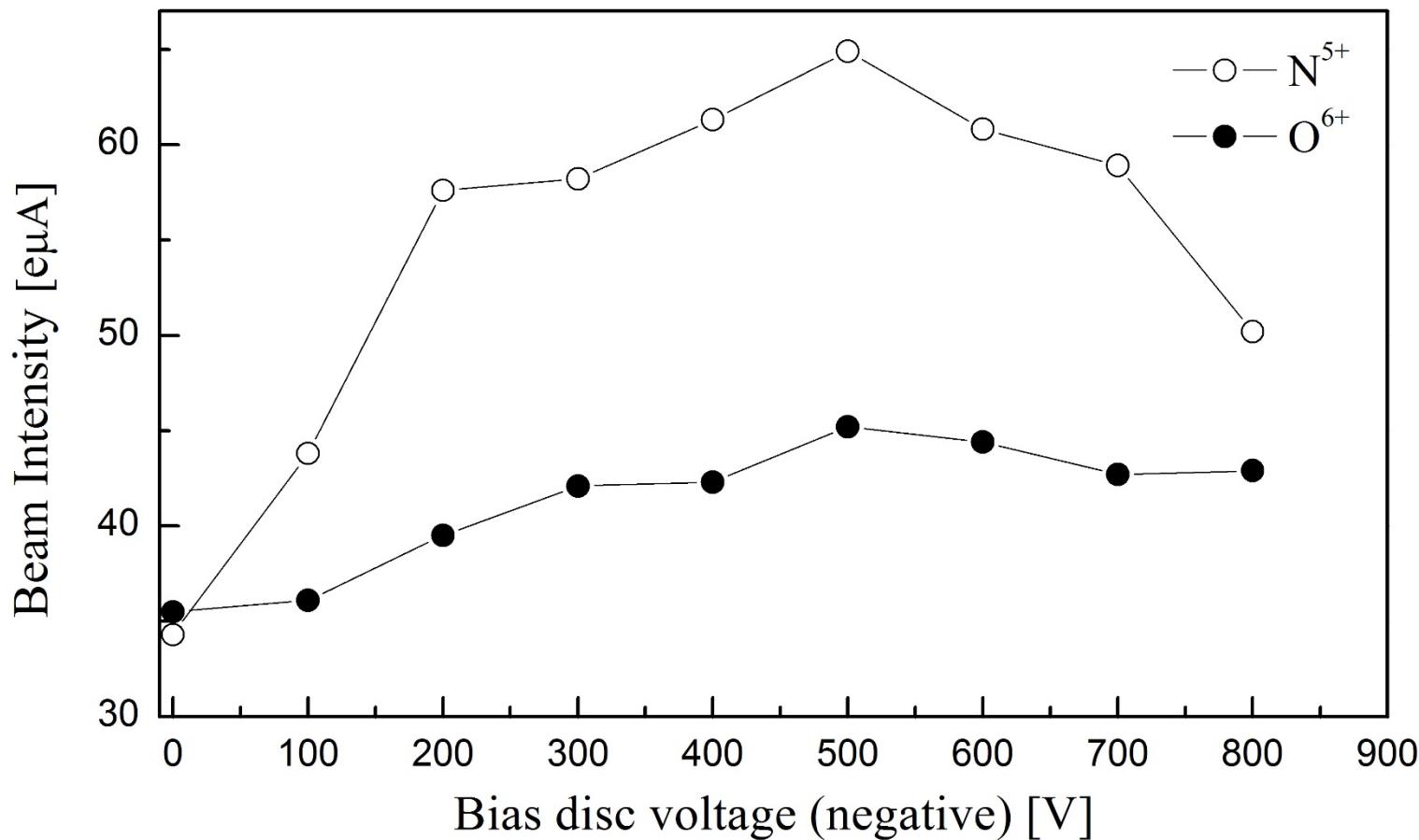


Result as a function of gas pressure



- ◆ The gas pressure represents the vacuum range of plasma chamber at the injection side after supplying the gas.
- ◆ The optimum beam intensities is found when the gas pressure is supplied around 2×10^{-6} Torr.

Result as a function of bias disc voltage



- ◆ the beam intensities of N^{5+} and O^{6+} as a function of biased disc voltage (negative)
- ◆ The beam intensities are increased at the voltage about -500 V.

Conclusion & Future Plan

- We successfully produced charged heavy ions at microwave power 1 kW with 28 GHz microwave.
- We measured x-ray spectra from KBSI 28GHz ECR ion source.
- We will shield the plasma chamber by use the Pb or Ta sheet, which thickness is more than 2 mm.
- The magnetic field must be increased to the design value
- We need further improvement of the performance of 28GHz KBSI ECR ion source.

